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CONFIRMATION NO. 3409

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/586,953	07/25/2006 RULE	438	1792	128832

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** CONTINUING DATA *****

This application is a 371 of PCT/JP05/00839 01/24/2005

** FOREIGN APPLICATIONS *****

JAPAN 2004-025923 02/02/2004

** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **

03/31/2007

Foreign Priority claimed 35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
Verified and /G. NAGESH NAGESH RAO/ Examiner's Signature		Initials	JAPAN	3	52	9
Acknowledged						

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TITLE

Silicon single crystal, a silicon wafer, an apparatus for producing the same, and a method for producing the same

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